



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi Yamazaki et al.

Application No.: 09/970,766

Filed: October 5, 2001

For: METHOD OF MANUFACTURING
SEMICONDUCTOR SUBSTRATE,
SEMICONDUCTOR SUBSTRATE, ELECTRO-
OPTICAL APPARATUS AND ELECTRONIC
EQUIPMENT

Group Art Unit: 2811

Examiner: S. Hu

Docket No.: 110791

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**


Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination and entry and consideration of the Amendment After Final Rejection Under 37 C.F.R. §1.116 previously submitted on June 11, 2003 and the attached Supplemental Amendment Under 37 C.F.R. §1.114. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 143718 in the amount of ☒ \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

Jeffery M. Lillywhite
Registration No. 53,220

07/02/2003 CCHAU1 00000137 09970766

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750.00 OP

JAO:JML/vgp

Date: July 1, 2003

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**DEPOSIT ACCOUNT USE
AUTHORIZATION**
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

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